



HEC-DPSSL 2014

Research Center of Laser Fusion CAEP

27 March 2014, Oxford, United Kingdom



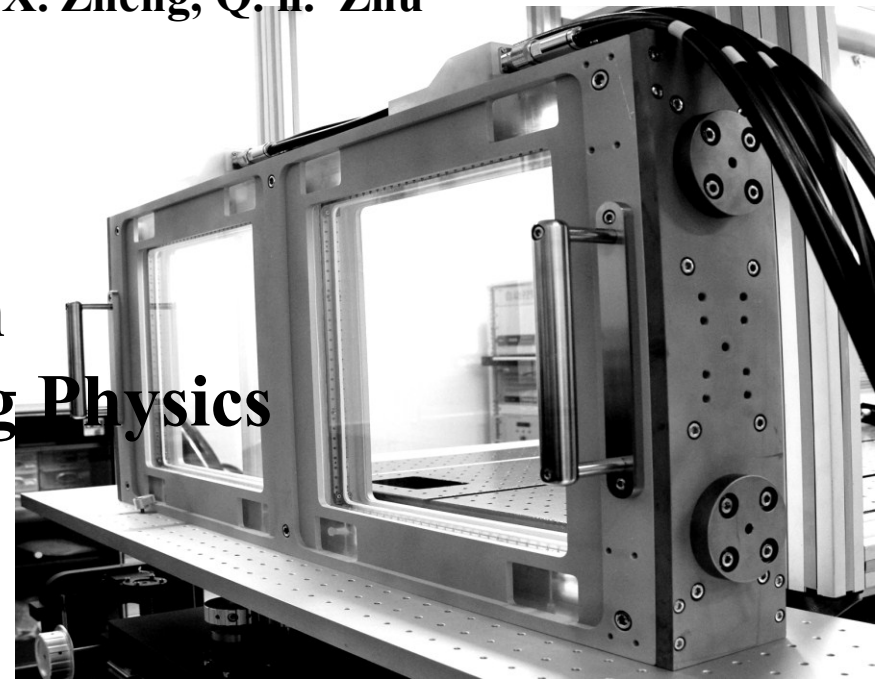
Design of a reflective PEPC for 100J/10Hz amplifier

Jun Zhang

J. G. Zheng, X. J. Zhang, D. S. Wu, X. L. Tian, K. X. Zheng, Q. h. Zhu

junzhang_my@163.com

**Research Center of Laser Fusion
Chinese Academy of Engineering Physics**





Outline

Research Center of Laser Fusion CAEP



- ◆ **Introduction**
- ◆ **Story of steps towards HEC-RF requirements**
- ◆ **Design and performances of a R-PEPC**
- ◆ **Summary**



Outline

Research Center of Laser Fusion CAEP



◆ Introduction

◆ Story of steps towards HEC-RF requirements

◆ Design and performances of a R-PEPC

◆ Summary

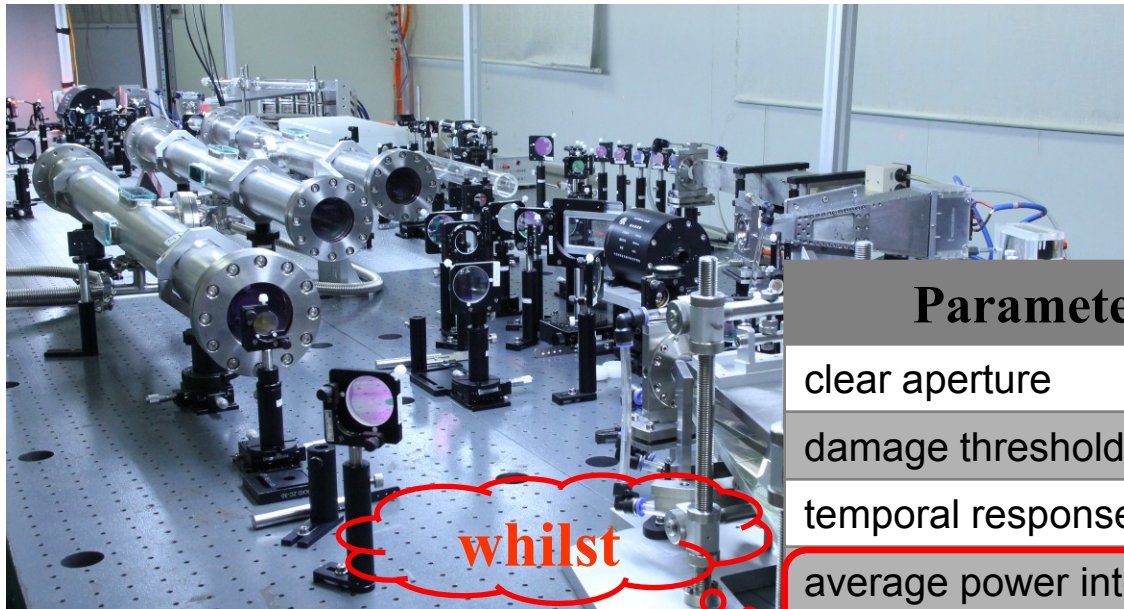


Introduction

Research Center of Laser Fusion CAEP



- ◆ Merits of multi-pass amplifying scheme have been validated in respect of high extraction efficiency, cost saving, and physical size reducing
- ◆ In this amplifier, an optical switch is required for laser pulse injecting, ejecting, and parasitic oscillation suppressing
- ◆ As for high energy, repetition rate operating, large laser facility



whilst

Parameter	Performance
clear aperture	multi-cm to tens of cm
damage threshold	mulit-J/cm ²
temporal response	nanoseconds-scale
average power intensity	tens W/cm ²
repetition rate	around 10 Hz



Introduction

Research Center of Laser Fusion CAEP



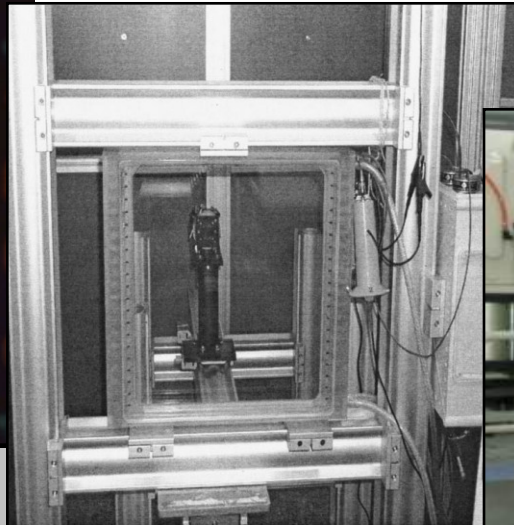
Meeting the required aperture size, damage threshold, temporal response

Using thin EO crystal while keeping switching voltage at a low level

Make it appropriate for HEC-rf operation



For NIF in LLNL



For LMJ in CEA



For SG-III in RCLF



Outline

Research Center of Laser Fusion CAEP

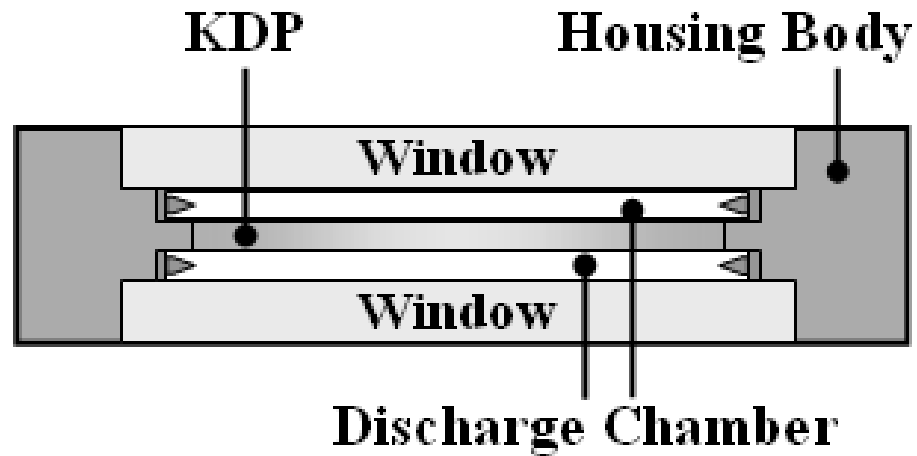


- ◆ Introduction
- ◆ **Story of steps towards HEC-RF requirements**
- ◆ Design and performances of a R-PEPC
- ◆ Summary

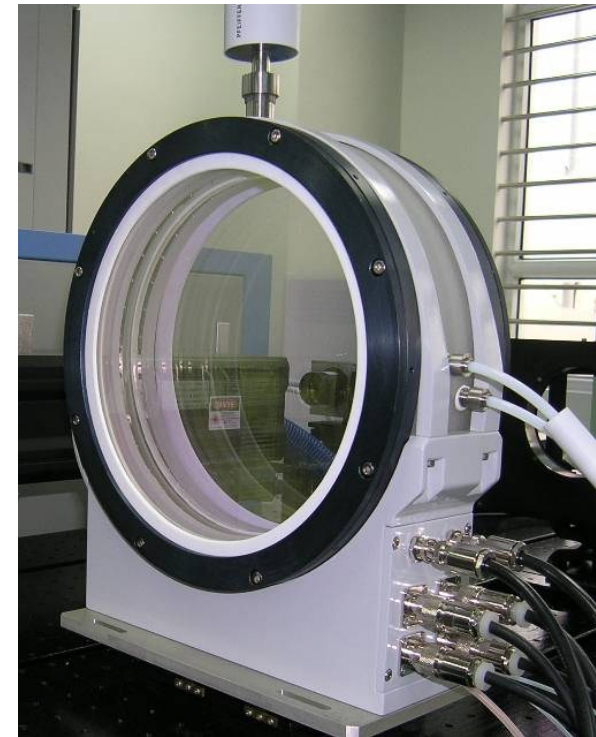


Briefly Introducing the concept of PEPC

Research Center of Laser Fusion CAEP



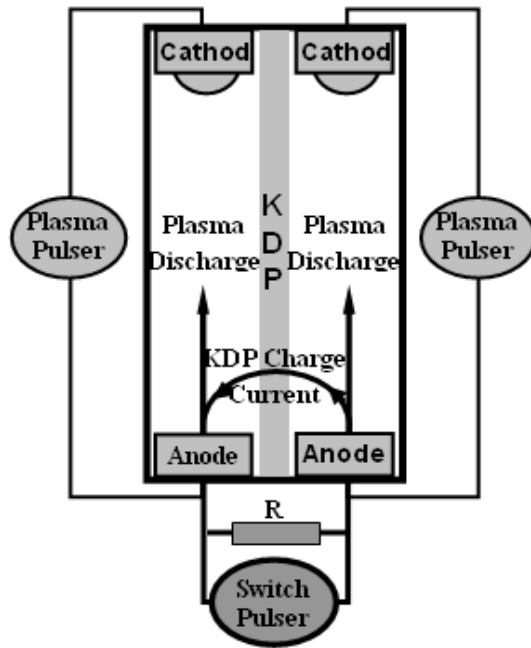
Schematic of the PEPC architecture





Two kinds operating mode

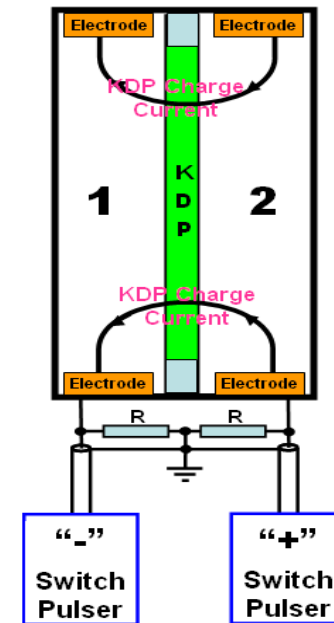
Research Center of Laser Fusion CAEP



Double pulse driven

S1: High-current ionizing
S2: Switching voltage

Only the switching voltage



Single pulse driven
(SPD)



Merits of SPD for HEC-RF application

Research Center of Laser Fusion CAEP

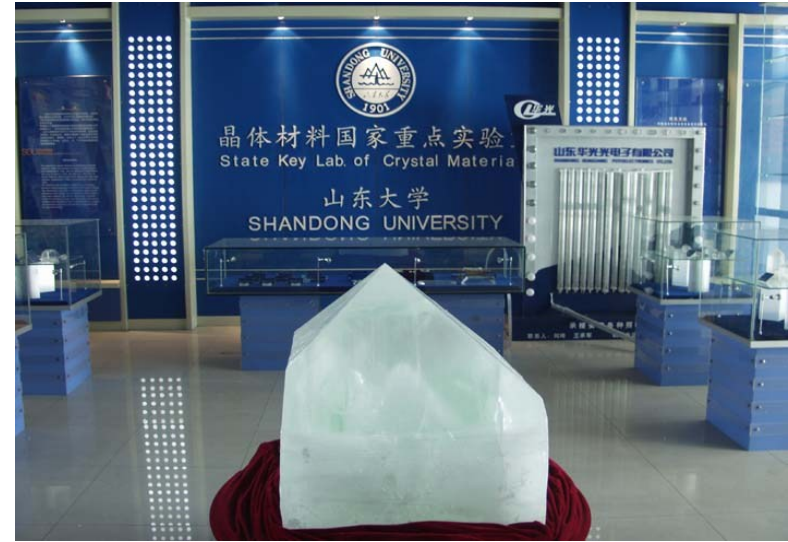
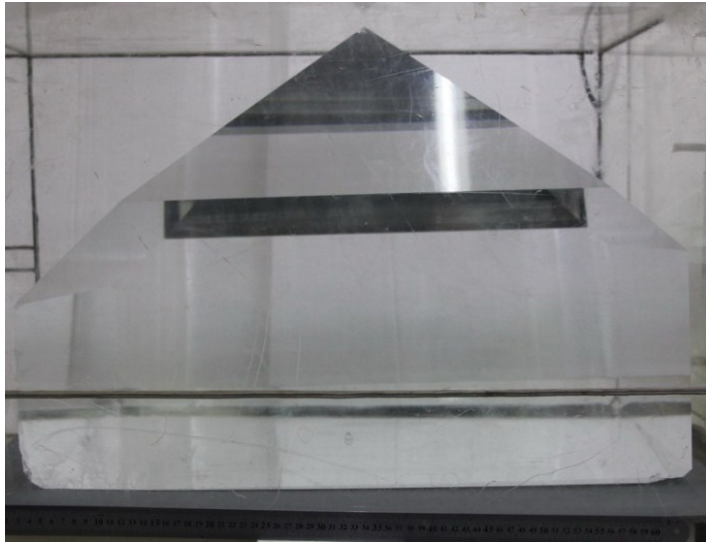


- ◆ **Without high-current pre-ionization process**
 - The gas discharge time is shortened from tens of ms to hundreds of ns.
 - Spotting optical elements, due to cathode sputtering, is reduced.
 - The heat deposition in crystal, heated by cathodes, is reduced.
- ◆ **The SPD mode is more suitable for rf application.**



Drawbacks of SPD for HEC-RF application

Research Center of Laser Fusion CAEP



- ◆ KDP, DKDP is only available EO crystal which meets requirement of large-dimensions.
- ◆ DKDP, with a lower absorption coefficient ($\sim 0.2\% \text{cm}^{-1}$) than that of KDP ($5\% \text{cm}^{-1}$), is the best choice at present.



Drawbacks of SPD for HEC-RF application

Research Center of Laser Fusion CAEP

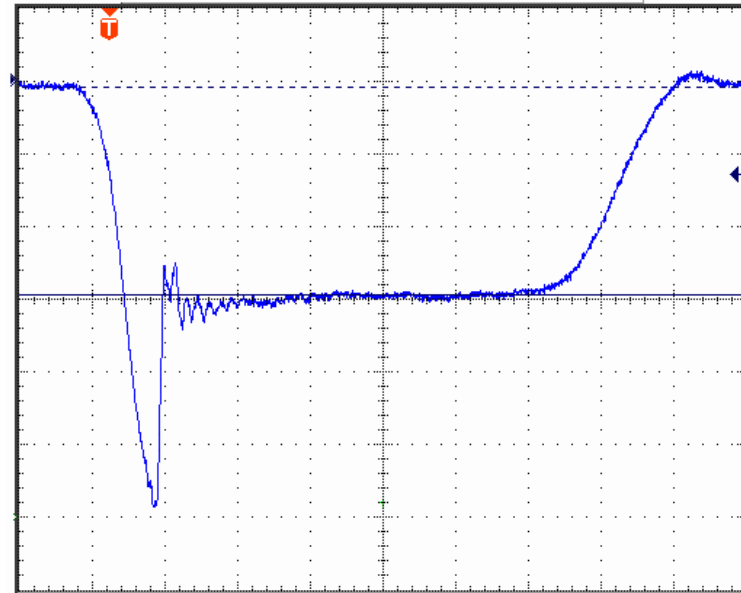
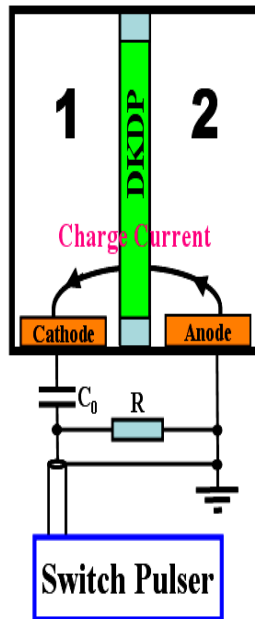


However,

- ◆ **The needed voltage to breakdown the gas ≥ 12 kV, so SPD PEPC generally uses KDP as electro-optic crystal because of its high half-wave voltage.**
- ◆ **The half-wave voltage of DKDP is ~ 6.8 kV, that is too low to realize single pulse driven PEPC.**



Capacitance dividing voltage method for SPD DKDP PEPC



- ◆ A dividing capacitor is arranged in the circuit.
- ◆ Appropriate C_0 and U makes that SPD DKDP PEPC works.

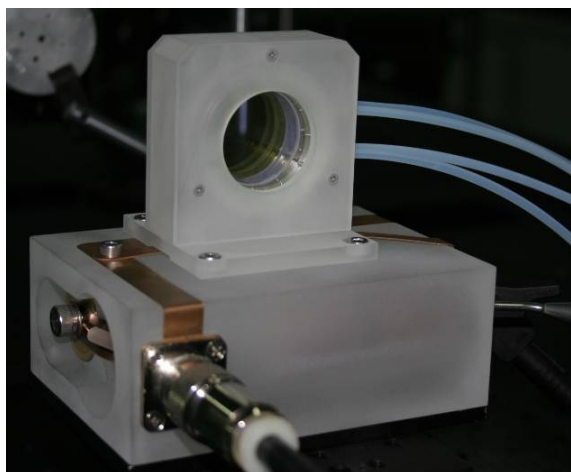


A single pulse driven DKDP PEPC

Research Center of Laser Fusion CAEP



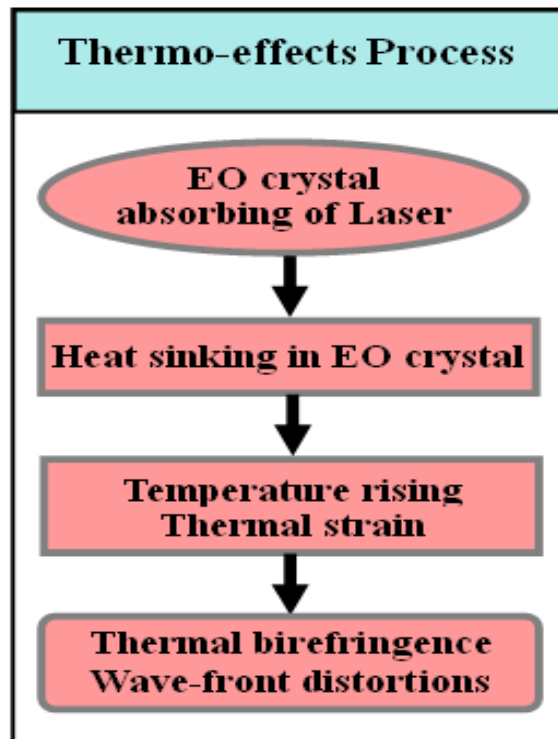
- ◆ A PEPC is fabricated to examine this scheme
- ◆ $\sim 10^5$ shots operating shows no degrading of transmission rate.
- ◆ Neither depolarization loss is observed in 2h continuous operating.



Parameter	Performance
Clear aperture: $\phi 30\text{mm}$	Rising time: 9.8ns
DKDP thickness: 3mm	Rep. rate: 10Hz
Driving voltage: $< 15\text{kV}$	Insertion loss: 98.6%
Extinction ratio: $> 10^3: 1$	Switching efficiency: $\sim 99.5\%$



Thermo-effects arising from DKDP absorption of laser

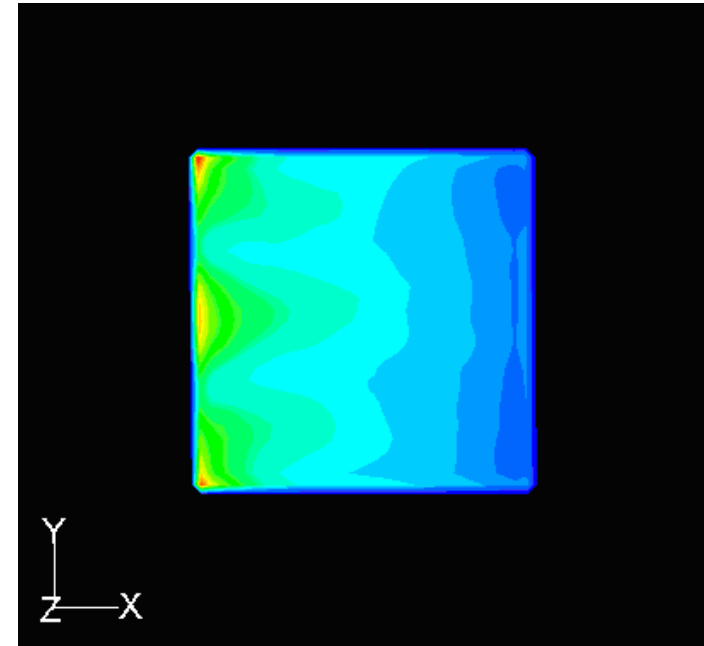
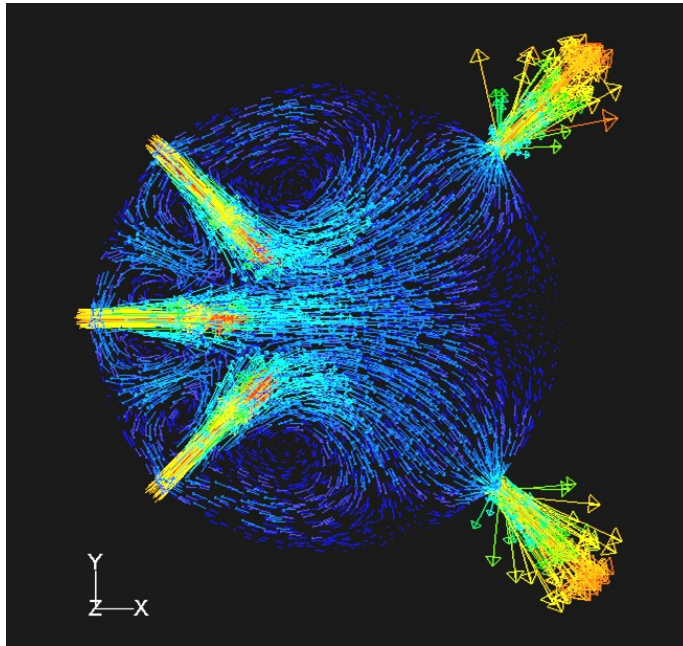


- ◆ Even though DKDP has a lower absorption coefficient, thermo-effects is remarkable.
- ◆ Optical switch is sensitive to thermo induced birefringence.
- ◆ The deposited heat must be removed in time.



Heat convection coefficient of operating gas

Research Center of Laser Fusion CAEP



- ◆ Optimizing gas-flow distribution and heat convection coefficient by CFD
- ◆ Unfortunately, low operating pressure results in a h_c of $\sim 10^{-4}$ W/cm²K.
- ◆ This h_c is too small to efficiently remove the deposited heat in crystal.

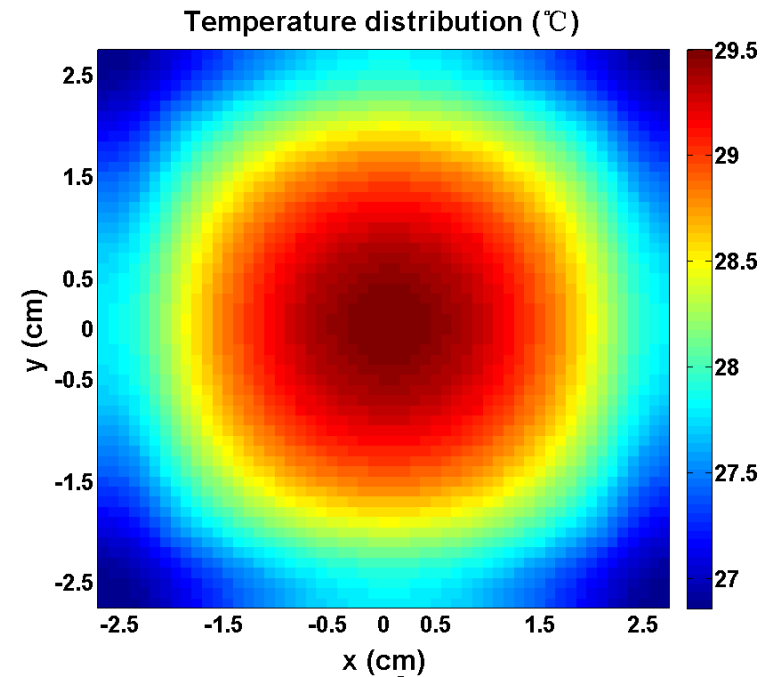
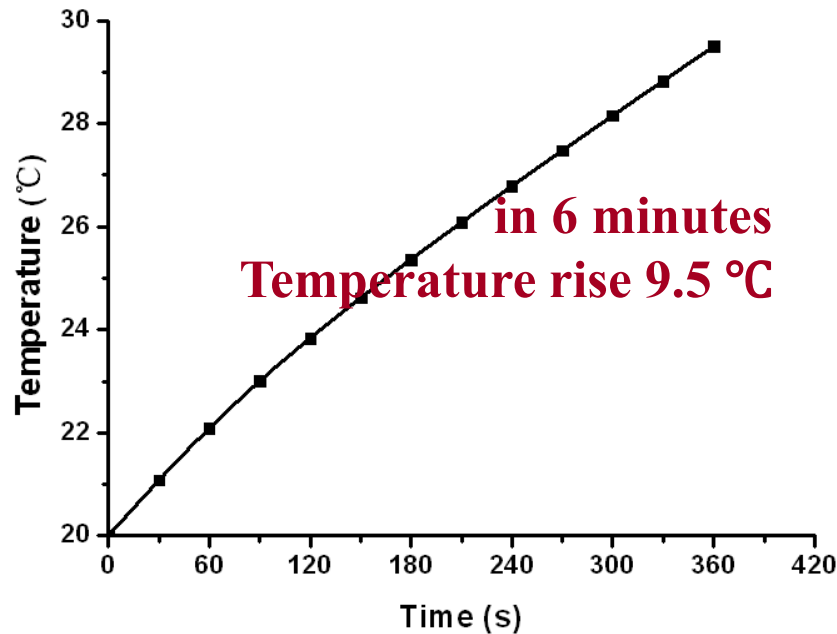


Quantitatively describing of thermo-effects

Research Center of Laser Fusion CAEP



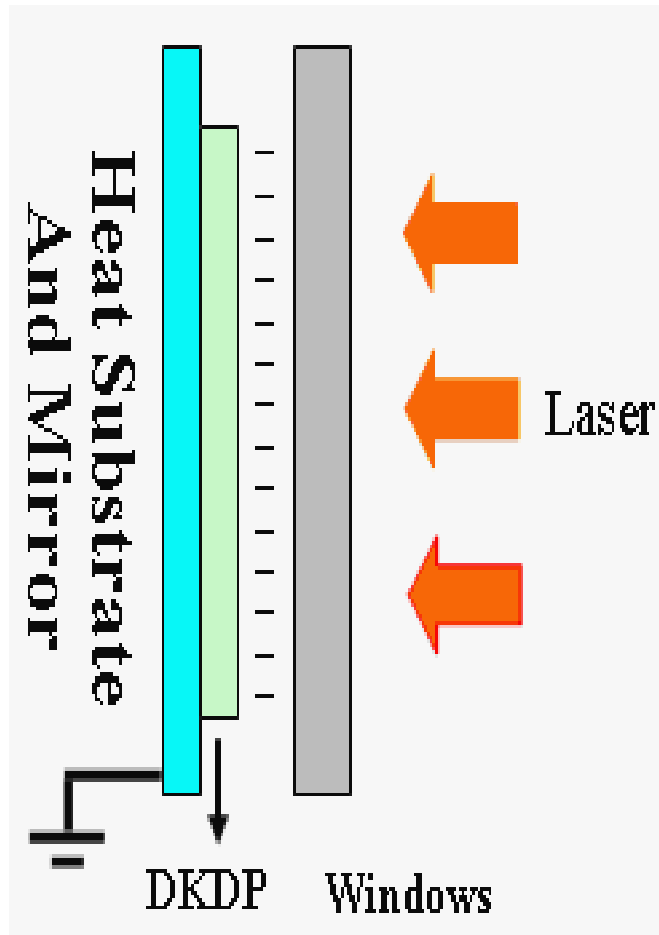
Supposing the laser average power intensity is 30 W/cm^2





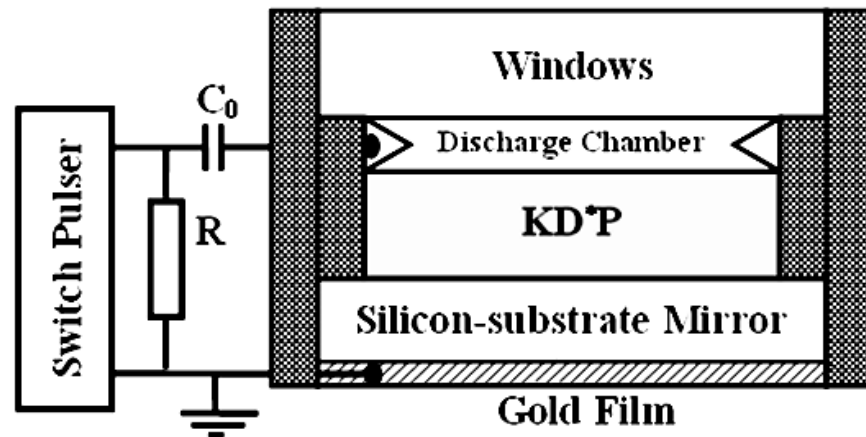
Demonstrating of the reflective PEPC concept

Research Center of Laser Fusion CAEP



DKDP is longitudinally cooled

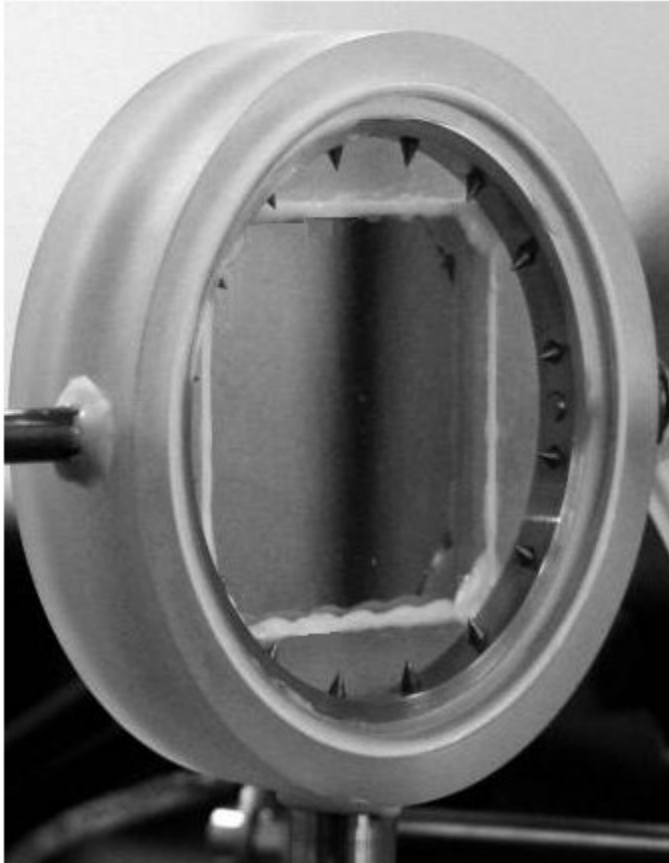
- ◆ Short heat-flux path-length
- ◆ large heat transfer area
- ◆ High cooling efficiency
- ◆ Small transverse temperature gradients





A reflective PEPC prototype

Research Center of Laser Fusion CAEP



“Cold” performances not changing

Parameter	Performance
clear aperture	40mm×40mm
Extinction ratio	~1000:1
Switching efficiency	99.6%
Driving voltage	12.5 kV
Rising time	11 ns
Shot-to-shot jitter	10 ns (mainly from driver)

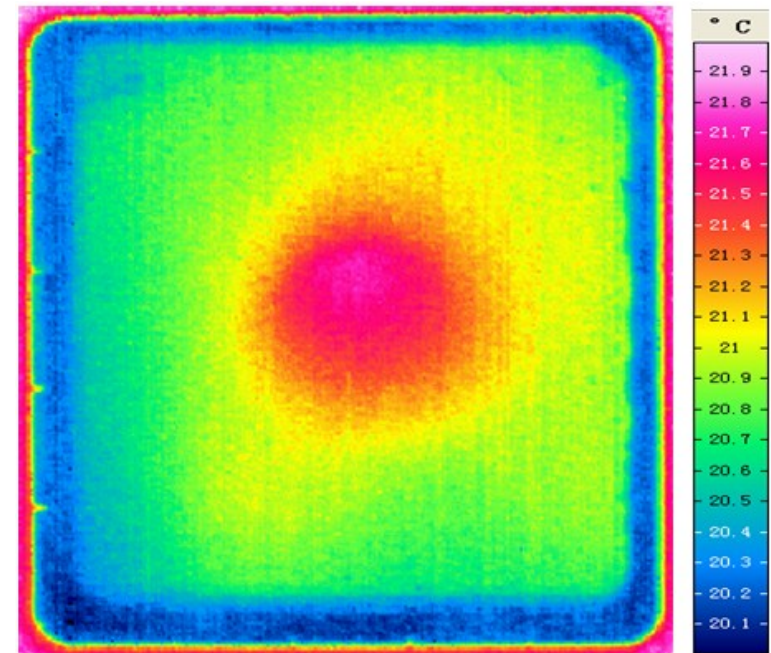
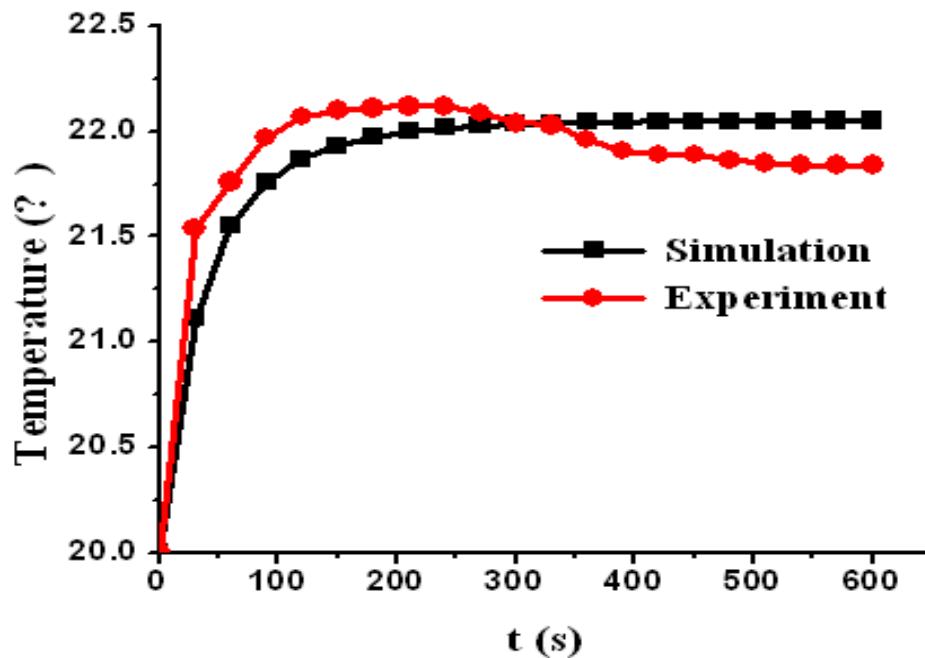


Thermal resistivity between DKDP and heat sink



Research Center of Laser Fusion CAEP

- ◆ Heating source: 980 nm laser, 50 W/cm², beam aperture Φ20mm
- ◆ Measured thermal resistivity: around 65 cm²K/W





Outline

Research Center of Laser Fusion CAEP



- ◆ Introduction
- ◆ Story of steps towards HEC-RF requirements
- ◆ **Design and performances of a R-PEPC**
- ◆ Summary

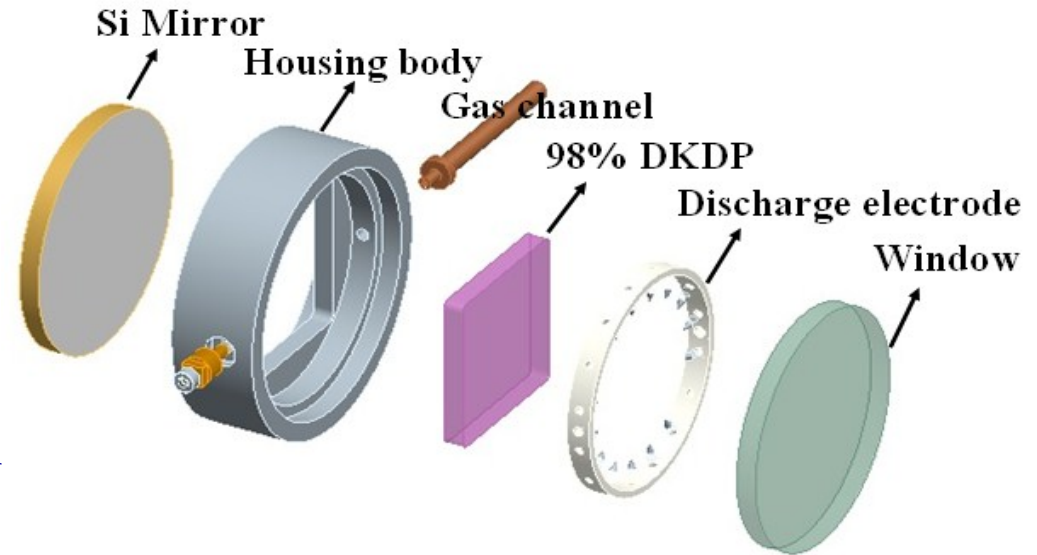


Design of a R-PEPC for 100J/10Hz amplifier

Research Center of Laser Fusion CAEP



Output fluence is 5 J/cm²
For 100 J/10 Hz application
Clear aperture: 45mm×45mm

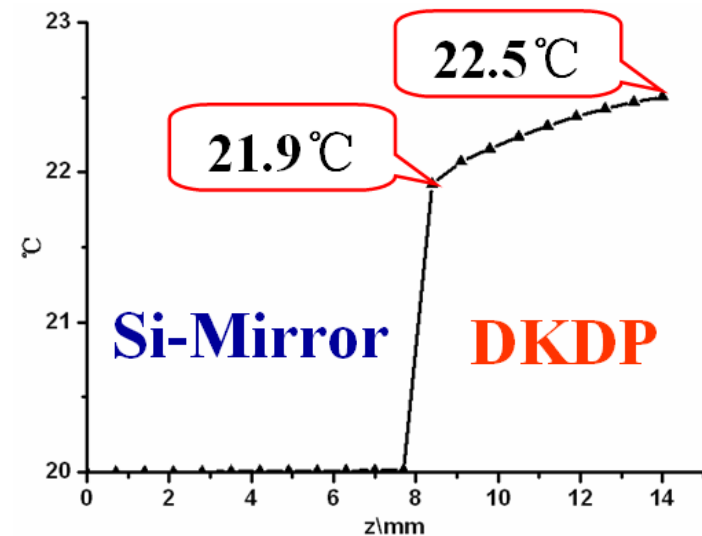
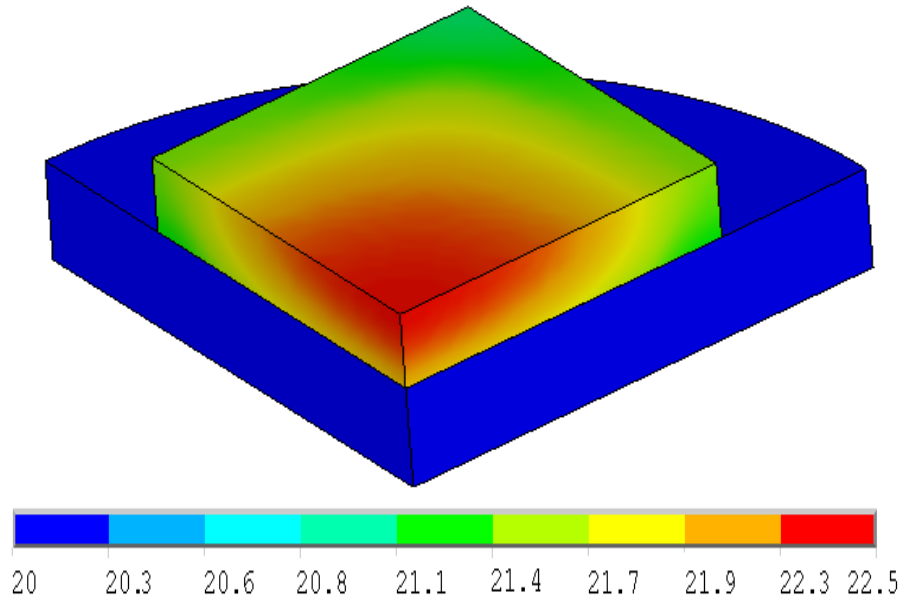


- ◆ DKDP: 55mm×55mm×6mm
- ◆ Si Mirror: $\Phi 80\text{mm} \times 8\text{mm}$
- ◆ Matching impedance: 12.5 ohm
- ◆ Plasma Chamber: $\Phi 80\text{mm} \times 8\text{mm}$
- ◆ Insertion loss: 1.5%
- ◆ theory rising time: 2.5 ns
- ◆ Driving voltage: 15.5 kV



Predicted “hot” performances

Research Center of Laser Fusion CAEP

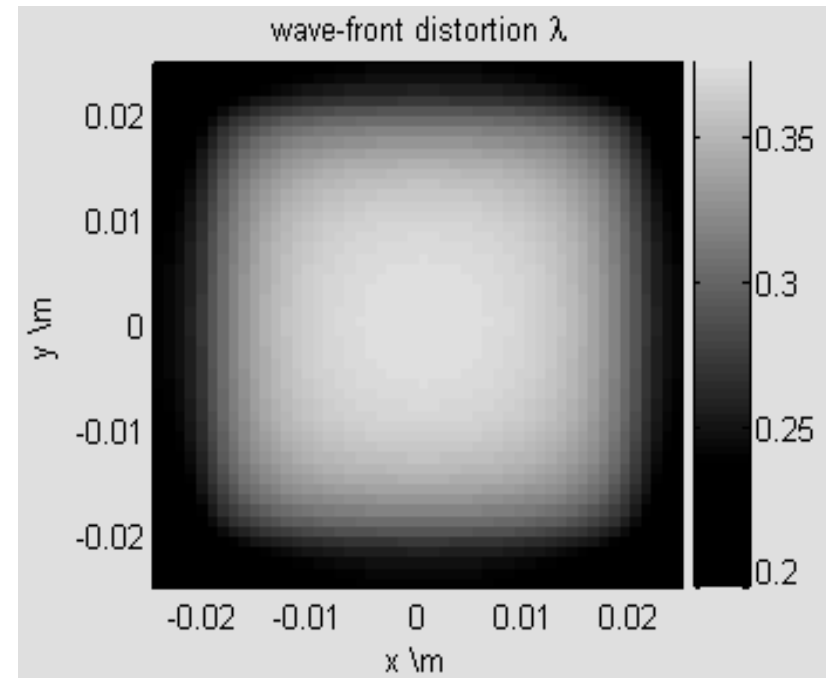
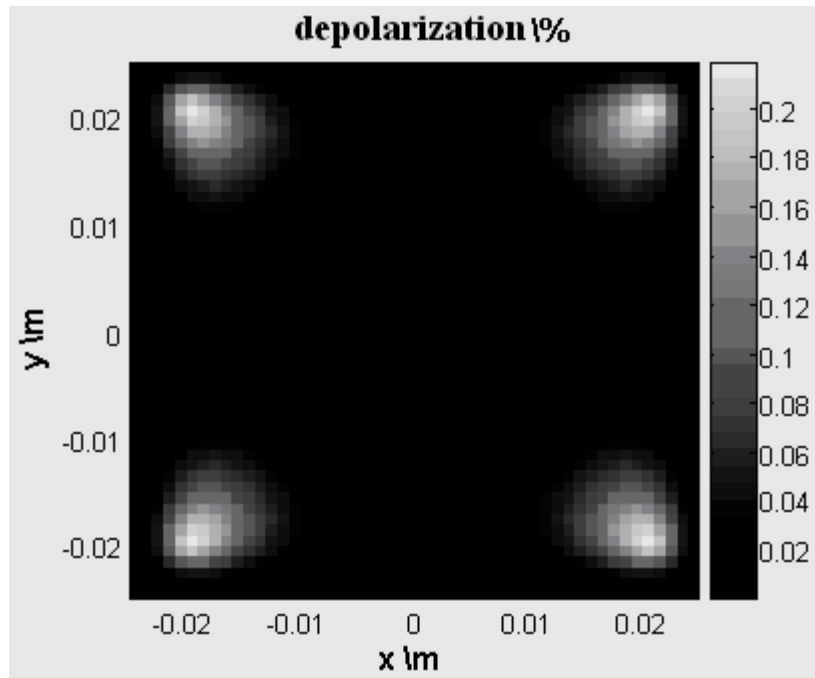


- ◆ At thermal steady-state, max temperature rise in DKDP is 2.5 °C, whereas temperature difference is 0.6 °C
- ◆ There is a temperature drop of 1.8 °C between DKDP and Si-mirror contact surfaces due to contact thermal resistivity.



Depolarization & wavefront distortion

Research Center of Laser Fusion CAEP



- ◆ Maximal depolarization: 0.22%, located at corners of the laser beam
- ◆ Average depolarization: 0.02%, over the laser beam
- ◆ Wavefront distortion: 0.18 λ ($\lambda=1030$ nm)



Outline

Research Center of Laser Fusion CAEP



- ◆ Introduction
- ◆ Story of steps towards HEC-RF requirements
- ◆ Design and performances of a R-PEPC
- ◆ **Summary**



Summary

Research Center of Laser Fusion CAEP



- ◆ We introduce challenges that PEPC encounters for HEC-rf application
 - One single pulse driven DKDP PEPC
 - Thermo-effects
- ◆ and their tactics are demonstrated.
 - Capacitance dividing voltage method
 - Reflective design and conduction-cooling
- ◆ At last, we present the design of a R-PEPC for 100J/10Hz amplifier application, and its performances are discussed.

A group of nine people, seven men and two women, are posing for a group photo outdoors. They are arranged in two rows: five people in the back row and four in the front row. The setting appears to be a park or campus area with a large, dark, abstract stone monument in the background. To the left, there is a multi-story building with a light-colored facade and several windows. The ground is paved with light-colored tiles. The overall atmosphere is casual and professional. Overlaid on the bottom half of the image is the text "Thanks for your attention!" in a large, colorful, rainbow gradient font with a white outline.

Thanks for your attention!